

		Type	L #	Hits	Search Text	DBs	Time Stamp	Cor ro mm en ts	De fi ni ti on	Er ro rs
1	BRS	L1	2		((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:29			
2	BRS	L3	39		("438"/\$).ccls. and (coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:30			

		Type	L #	Hits	Search Text	DBs	Time Stamp	Error Cor mm en ts	Error Cor mm De en ti on
3	BRS	L5	25		((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve) and (air or bubble) and buffer with tank	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:54		

				Type	L #	Hits	Search Text	DBs	Time Stamp	Cor ro mm en ts	De fi ni ti on	Er ro rs
4	BRS	L6	26				((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve) and (air or bubble) and buffer with tank	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:54			

								Co mm en ts	Er ro r n ti on	Er ro r n ti on
Type	L #	Hits	Search Text	DBs	Time Stamp					
5	BRS	L7	4	(438/780).ccls. and ((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:54				

				Type	L #	Hits	Search Text	DBs	Time Stamp	Cor r em en ts	De fi ni ti on	Er ro rs
6	BRS	L8	1				(438/781).ccls. and ((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:55			

		Type	L #	Hits	Search Text	DBs	Time Stamp	Cor r em en ts	De fi ni ti on	Error rs
7	BRS	L10	2		(438/758).ccls. and ((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:55			

		Type	L #	Hits	Search Text	DBs	Time Stamp	Er ro Co mm en ts	ro r e ni ti on	Er ro rs
8	BRS	L9		11	(438/689).ccls. and ((coat\$6 or spray\$4 or spin adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/14 22:56			